



IPO  
PATENT  
8017-1096

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In re application of

Yasuaki TSUCHIYA et al. Conf. 4719

Application No. 10/622,735 Group 1755

Filed July 21, 2003 Examiner M. Marcheschi

SLURRY FOR POLISHING COPPER-BASED METAL

**FURTHER SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of these items is that these references were cited by the Patent Office of the People's Republic of China in the corresponding Chinese Application Serial No. 03152491.5. A copy of the Chinese Official Action in which they were cited is attached hereto, **with an English translation of the Chinese Official Action.**

JP 2002-075927 corresponds to the cited Chinese reference CN 1340583A.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a

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counterpart foreign application not more than three months prior to the filing of this Statement.

Charge the Information Disclosure Statement petition fee of \$180 to deposit account No. 25-0120.

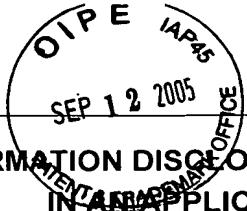
Respectfully submitted,

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ES/ RJP/fb

September 12, 2005



<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  (Use several sheets if necessary)	Attorney Docket No.: <b>8017-1096</b>	Application No.: <b>10/622,735</b>
Applicant: <b>Yasuaki TSUCHIYA et al.</b>		
Filing Date: <b>July 21, 2003</b>		Group Art Unit: <b>1755</b>

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

EXAMINER	DATE CONSIDERED
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EXAMINER: \_\_\_\_\_ DATE CONSIDERED \_\_\_\_\_

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* English Abstract provided for the Examiner's convenience